



Applicants:

N. YAMAMOTO

Application No.:

10/787,437

Filed:

February 27, 2004

For:

METHOD OF MANUFACTURING A DUAL GATE SEMICONDUCTOR DEVICE WITH A POLY-METAL

ELECTRODE

Art Unit:

2822

Examiner:

I. SOWARD

<u>AMENDMENT</u>

MS: AMENDMENTS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 5, 2005

Sir:

In response to the Office Action dated April 5, 2005, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Specification;

Amendments to the Claims; and

Remarks are included following the amendments.